



Information & Control NA TC Chapter

November 9, 2022

9:00 AM – 3:00 PM Pacific Time

SEMI HQ, Milpitas

AGENDA

1 Welcome/Call to Order

- 1.1 Introductions
- 1.2 Required Meeting Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)
- 1.3 Agenda Review
- 1.4 SVM Software Review

2 Review of Previous Meeting Minutes (including open Action Items review)

3 Ballot Review (including safety and IP checks)

#	When	TF	Details
6932	Cycle 7-22	DDA TF	Reapproval for SEMI E121-1017, Guide for Style and Usage of XML for Semiconductor Manufacturing Applications
6850	Cycle 7-22	GEM300 TF	Reapproval of SEMI E109.1-1110, Specification for SECS-II Protocol for Reticle and Pod Management (RPMS)
6969	Cycle 7-22	GEM300 TF	Reapproval of SEMI E123-0217, Specification for Handler Equipment Specific Equipment Model (HSEM)
6968	Cycle 7-22	GEM300 TF	Reapproval of SEMI E122.1-0703 (Reapproved 1109), Specification for SECS-II Protocol for Tester Specific Equipment Model (TSEM)
6967	Cycle 7-22	GEM300 TF	Reapproval of SEMI E122-0217, Specification for Tester Equipment Specific Equipment Model (TSEM)
6966	Cycle 7-22	GEM300 TF	Reapproval of SEMI E109-1017, Specification for Reticle and Pod Management (RPMS)
6965	Cycle 7-22	GEM300 TF	Reapproval of SEMI E88-0318, Specification for AMHS Storage SEM (Stocker SEM)
6964	Cycle 7-22	GEM300 TF	Reapproval of SEMI E82-0318, Specification for Interbay/Intrabay AMHS SEM (IBSEM)
6963	Cycle 7-22	GEM300 TF	Reapproval of SEMI E30.5-0217, Specification for Metrology Specific Equipment Model (MSEM)
6962	Cycle 7-22	GEM300 TF	Reapproval of SEMI E30.1-0217, Specification for Inspection and Review Specific Equipment Model (ISEM)
6946	Cycle 7-22	DDA TF	Line Item Revision to SEMI E132, Specification For Equipment Client Authentication and Authorization and SEMI E132.2, Specification for Protocol Buffers for Equipment Client Authentication and Authorization (ECA)
6947	Cycle 7-22	DDA TF	Line Item Revision to SEMI E179-0320, Specification for Protocol Buffers Common Components



6859A	Cycle 7-22	GEM300 TF	Revision to SEMI E116-0518 Specification for Equipment Performance Tracking (EPT) and E116.1-0707 (Reapproved 0518) Specification for SECS-II Protocol for Equipment Performance Tracking (EPT)
6572A	Cycle 7-22	GEM300 TF	Revision to SEMI E30-0418: Specification for The Generic Model for Communications and Control of Manufacturing Equipment (GEM)
6851	Cycle 7-22	GEM300 TF	Reapproval of SEMI E123.1-0703 (Reapproved 1109), Specification for SECS-II Protocol for Handler Specific Equipment Model (HSEM)

4 Staff Report

5 Liaison Reports

- 5.1 Japan TC Chapter
- 5.2 Korea TC Chapter
- 5.3 Taiwan TC Chapter
- 5.4 China TC Chapter

6 Subcommittee & Task Force Reports

- 6.1 Process Control System (PCS) Task Force – James Moyne / Chris Maloney
- 6.2 Fab & Equipment Computer and Device Security (CDS) Task Force – Ryan Bond / Richard Howard
- 6.3 Advanced Backend Factory Integration (ABFI) Task Force – Dave Huntley / Brian Rubow / Luis Lim
- 6.4 Graphical User Interface (GUI) Task Force – Tami Tracey / Frank Summers
- 6.5 Diagnostic Data Acquisition (DDA) Task Force – Brian Rubow / Albert Fuchigami
- 6.6 Energy Saving Equipment Communication (ESEC) Task Force – Andreas Neuber / Gerald Shelley
- 6.7 GEM300 Task Force – Brian Rubow / Chris Maloney



7 Old Business

- 7.1 Standards due for Five-Year Review
- 7.2 SNARFs approaching Three-Year Document Development Project Period

8 New Business

- 8.1 New TFOFs & SNARFs
- 8.2 New Ballot(s) Submission Summary
- 8.3 iNEMI Liaison Request

9 New Action Item Review

10 Next Meetings Schedule (TBD)

Date/Time/Location

- TBD

11 Adjournment

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